

Search Notes

Application/Control No.

10/650,601

Examiner

José R. Díaz

Applicant(s)/Patent under
Reexamination

LIN, SHI-CHI

Art Unit

2815

SEARCHED

Class	Subclass	Date	Examiner
438	408,409, 429,431, 433, 447,450	4/18/2005	JRD
438	960	4/18/2005	JRD
257	E21.547	4/18/2005	JRD
257	E21.888	4/18/2005	JRD
257	E21.288	4/18/2005	JRD
257	E21.545	4/18/2005	JRD
257	E21.551	4/18/2005	JRD
257	E21.565	4/18/2005	JRD

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Text Search East (see attachment)	4/18/2005	JRD